



**UNITED STATES PATENT AND TRADEMARK OFFICE**

**COMMISSIONER OF PATENTS**

March 3, 2005

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Two Embarcadero Center, Eighth Floor  
San Francisco, CA 94111-3834

In re Application of:  
Mineo Nomoto, et al  
Serial No: 10/082,430                      On Petition  
Filing Date: February 22, 2002  
For: METHOD AND APPARATUS FOR MEASURING THICKNESS OF THIN FILM AND  
DEVICE MANUFACTURING METHOD USING SAME

In response to the petitions received April 28, 2004, to withdraw the holding of abandonment  
in the above application.


The petition is Granted.

The above-identified application became abandoned for failure to reply with the meaning of 37 C.D.R 1.113  
in a timely manner to the Notice to File Missing Parts of Nonprovisional Application mailed March 22, 2002.  
Which set forth a shortened statutory period for reply of two months. Accordingly, the above-identified  
application became abandoned May 23, 2002. The notice of abandonment was mailed on October 2, 2002.

The evidence submitted is sufficient to establish that the petitioners responded to the Notice to File Missing  
Parts of Nonprovisional Application Papers on July 1, 2002.

The application was abandoned in error. The office regrets any inconvenience this may have caused the client.

Telephone inquiries concerning this application may be directed to Doshie E. Day (703) 308-3640.

  
Doshie E. Day  
Program Management Assistant  
Office of Initial Patent Examination